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Substitute for form 1449A/PTO

(use as many sheets as necessary)

Complete if Known

Application Number	09/295,607
Filing Date	4-22-1999
First Named Inventor	Shunpei YAMAZAKI et al.
Group Art Unit	2811
Examiner Name	Steven Loke
Attorney Docket Number	740756-1961

Sheet	1	of	1
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Examiner Signature	Loke		Date Considered 1/10/03

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Complete if Known

Application Number	09/295,607
Filing Date	April 22, 1999
First Named Inventor	Shunpei YAMAZAKI et al.
Art Unit	2811
Examiner Name	Steven Ho Yin Loke
Attorney Docket Number	740756-1961

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of

U.S. PATENT DOCUMENTS

Examiner Initials [*]	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
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Examiner Initials [*]	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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Loke		JP 02-105115	04-17-1990	Saburo Oikawa et al.		AB
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		JP 60-154660	08-04-1985	Seikosha Suwa		AB
		JP 63-296379	12-02-1988	Hiroya SATO et al.		AB

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Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Loke		Ito et al. "Thin Film Technology of VLSI" pp 87-88, published on September 30, 1986 by Maruzen Co., Ltd. (with English Abstract)	
Loke		Tokuyama et al., "VLSI Manufacturing Technology", pp. 194-195, Published on January 14, 1989 by Nikkei BP Co., Ltd. (with English Abstract)	
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